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confirmation no. 5057

Applicant Feng Chen Attorney Docket: CS03-039

Response to Office Action dated 2006-09-25

To: Commissioner of Patents

P.O. Box 1450 Alexandria, VA 22313-1450

From: William J. Stoffel 1735 Market St - Ste A455

Reg no. 39,390 Philadelphia, PA 19103-7502 USA

Customer no. 30,402

Work 215-670-2455 Fax 267-200-0730

Subject:

S/N 10/720,409 Inventor Feng Chen Confirmation no. 5057

Attorney Docket: CS03-039

File date: 11/24/2003

Title: CMP Polishing Heads Retaining Ring Groove Design for Microscratch

Reduction

Group Art Unit: 3723 Examiner: Shakeri

RESPONSE UNDER 37 CFR 1.116- EXPIDITED PROCEDURE - EXAM GROUP 3723-

RESPONSE TO OFFICE ACTION DATED 2006-09-25

Dear Sir:

Enclosed is a Response to Office Action dated 2006-09-25. Please consider the

following remarks:

CERTIFICATE OF MAILING OR FACSIMILE TRANSMISSION Total 28 Pages in this Fax

I hereby certify that this correspondence is being:

[_] FAXED to the central facsimile number of patent and trademark office at the following number (571) 273-8300 or

[_] deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450; on the date below.

Signature / William J. Stoffel / DATE November 27, 2006

William J. Stoffel Reg. No. 39,390 Customer number 30402

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This response to Office Action has the following sections:

- AMENDMENTS TO THE CLAIMS are reflected in the listing of claims that begin on the next page (p. 3)
- REMARKS/ARGUMENTS begin on the page following the previous section (p. 10)